

# Supplementary

## Oriented Bi<sub>2</sub>Te<sub>3</sub>-based films enabled high performance planar thermoelectric cooling device for hot spot elimination

Guoying Dong<sup>1,#</sup>, Jianghe Feng<sup>1,#</sup>, Guojuan Qiu<sup>1,#</sup>, Yuxuan Yang<sup>2</sup>, Haijun Wu<sup>2,\*</sup>, Qiyong Chen<sup>3</sup>, Yang Xiong<sup>1</sup>, Yifeng Ling<sup>1</sup>, Lili Xi<sup>3</sup>, Chen Long<sup>1</sup>, Jibao Lu<sup>1</sup>, Yixin Qiao<sup>1</sup>, Guijuan Li<sup>1</sup>, Juan Li<sup>1\*</sup>, Ruiheng Liu<sup>1,\*</sup>, Rong Sun<sup>1</sup>

<sup>1</sup>Shenzhen Institute of Advanced Electronic Materials, Shenzhen Institute of Advanced Technology, Chinese Academy of Sciences, Shenzhen 518055, China

<sup>2</sup>State Key Laboratory for Mechanical Behavior of Materials, Xi'an Jiaotong University, Xi'an 710049, China

<sup>3</sup>Materials Genome Institute, Shanghai University, Shanghai 200444, China

# These authors contribute equally to this work.

\*Corresponding authors: [wuhajunnavy@xjtu.edu.cn](mailto:wuhajunnavy@xjtu.edu.cn); [j.li1@siat.ac.cn](mailto:j.li1@siat.ac.cn); [rh.liu@siat.ac.cn](mailto:rh.liu@siat.ac.cn)

### Materials and methods:

**Phase and Microstructure Characterization:** The room temperature X-ray diffraction (XRD) was carried out for obtained n-type Bi<sub>2</sub>Te<sub>3+x</sub> and p-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> films after the annealing process with Bruker D8 Advance SS/ 18 kW, which is equipped with Cu K $\alpha$  radiation ( $\lambda_1 = 1.54056 \text{ \AA}$ ,  $\lambda_2 = 1.54443 \text{ \AA}$ ) and a PIXcel detector, the current maintained at 40 mA and the working voltage was set as 40 kV. The field-emission scanning electron microscope (SEM, Thermo Scientific Apreo 2 S HiVac, 5 kV) equipped with an energy dispersive spectroscopy (EDS) is adopted to characterize the microstructure and composition. The orientation factor  $F$  of the films were calculated using the formula  $F = (P_i - P_0)/(1 - P_0)$ , where  $P_i = I(00l)/\sum I(hkl)$ ,  $P_0 = I_0(00l)/\sum I_0(hkl)$ ,  $I(00l)$  is the (00l) plane diffraction intensity,  $P_i$  is the intensity ratio of the (00l) plane and  $I(hkl)$  is the diffraction peaks intensity.  $I(00l)$ ,  $P_0$  and  $I_0(hkl)$  were the parameters of the standard peaks (PDF no. 15-0863).

**TE Property Measurement:** The in-plane resistivity, Seebeck coefficient, carrier concentration and Hall mobility were simultaneously measured by a home-built apparatus from 300 to 420 K. The Seebeck coefficient was obtained from the slope of the thermopower vs. temperature difference from 0 to 5 K<sup>1</sup>. The thermopower was measured by two Nb wires welded to the thermocouple tips, the hot and cold side temperatures were measured by two K-type thermocouples attached to the opposite edges of the film. Four probes were connected to the films for resistivity and Hall coefficient measurement by the Van der Pauw technique under a reversible magnetic field of 1.5 T. The thermal conductivity is evaluated by transient photo-electro-thermal (TPET) technique<sup>2</sup> for both PI substrate and deposited PI films.

**DFT calculations:** Density Functional Theory (DFT) calculations were performed using the Vienna *ab initio* Simulation Package (VASP)<sup>3-5</sup>. The generalized gradient approximation (GGA) with the Perdew, Burke, and Ernzerhof (PBE) exchange-correlation functional was employed<sup>6</sup>. Structural optimizations were conducted until the forces on the atoms were less than 0.01 eV/ $\text{\AA}$ , with the electronic energy convergence criterion set to 10<sup>-6</sup> eV in the self-consistent calculations. A cutoff energy of 350 eV was used for all computations. The structural data for Bi<sub>2</sub>Te<sub>3</sub> and Sb<sub>2</sub>Te<sub>3</sub> were sourced from the MatHub-3d

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database<sup>7</sup>. Defect calculations were performed using a  $4 \times 4 \times 1$  supercell containing 240 atoms, with a  $\Gamma$ -centered  $2 \times 2 \times 1$  k-point mesh. The effective band structures (EBS) for the defective structures were calculated using the BandUP code<sup>8,9</sup>.

In this study, we calculated the binding energies of various surfaces, including the (100), (110), (015), and (001) facets. By varying the interlayer distance between the exfoliated layer and the bulk material and computing the system's energy at each state, we obtained a curve depicting the variation of the system's energy as a function of the interlayer distance. The energy of the system exhibited a trend of initial decrease followed by an increase, and ultimately reached convergence as the distance was extended. The binding energy is defined as the difference between the minimum point of the system's energy and its converged value:

$$E_b = (E_{vally} - E_{conv}) / A \quad (1)$$

where  $A$  is the surface area.  $E_{vally}$  and  $E_{conv}$  are the minimum and convergence energies of systems, respectively.

For perfect structures, both lattice constants and atomic positions for the supercells were relaxed, whereas for defective supercells, only the atomic positions were optimized. The formation energy of a point defect can be expressed as follows<sup>10,11</sup>:

$$E_f = E_{defect} - E_{pfect} - \sum_i n_i \mu_i \quad (2)$$

where  $E_{defect}$  is the total energy of the defective structure, and  $E_{pfect}$  is the total energy of the perfect supercell. In the defect structure,  $n_i$  represents the number of atoms of the  $i$ -th type (either host or impurity atoms) added to ( $n_i > 0$ ) or removed from ( $n_i < 0$ ) the supercell during defect formation.  $\mu_i$  denotes the chemical potential for the  $i$ -th type of the atom.

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## Figures

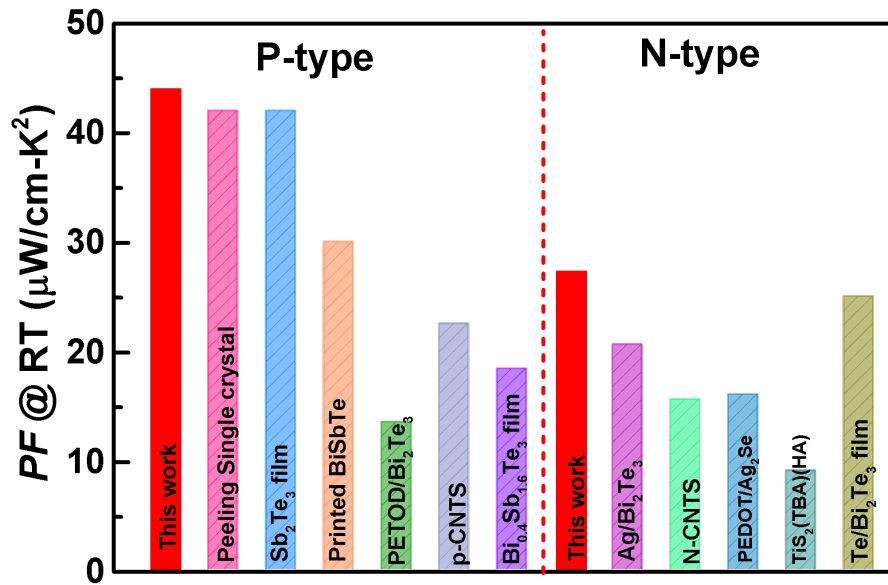


Fig. S1. **Power factor of film thermoelectric materials.** The room temperature power factor of films Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> (p) and Bi<sub>2</sub>Te<sub>3+x</sub> (x=0.17)(n) obtained in this work, with a comparison to that of other p-type<sup>12-16</sup> and n-type<sup>17-21</sup> thin films.

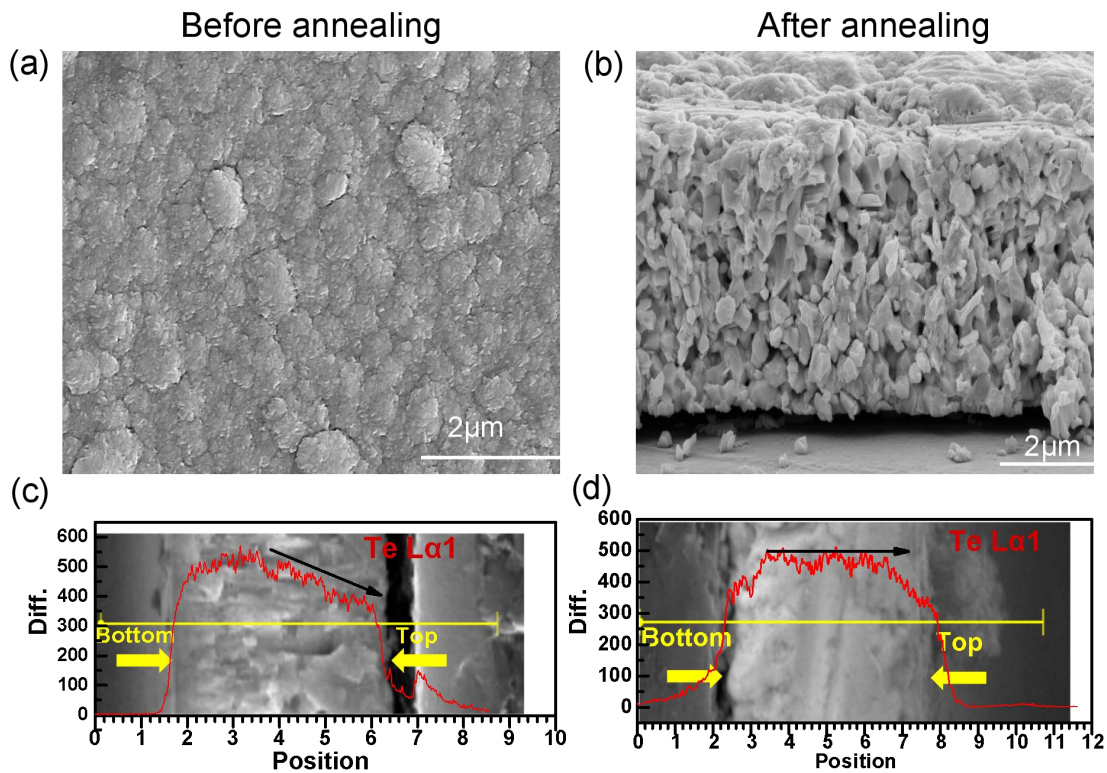


Fig. S2. **Te content distribution in the film from bottom to top.** The room temperature surface (a) and sectional (b) SEM images of n-type sample Bi<sub>2</sub>Te<sub>3+x</sub> (x=0.12), together with the Te element distribution on the sectional face from bottom to top before (c) and after (d) annealing process.

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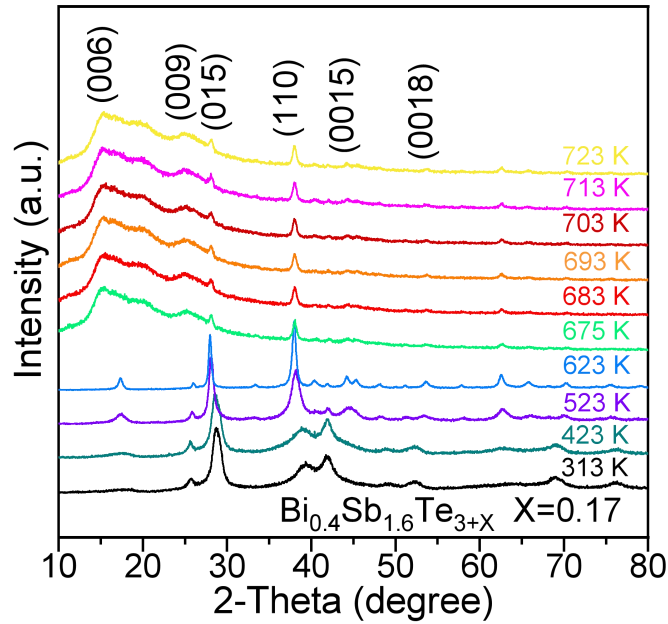


Fig. S3. **XRD patterns showing amorphous phase above 675 K.** Temperature-dependent X-ray diffraction data for sample  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0.17$ ) with temperature ranging from 313 K to 723 K. The halo peak in the  $2\theta$  range  $10\sim 30^\circ$  when temperature above 675 K indicating the appearance of amorphous phase Te.

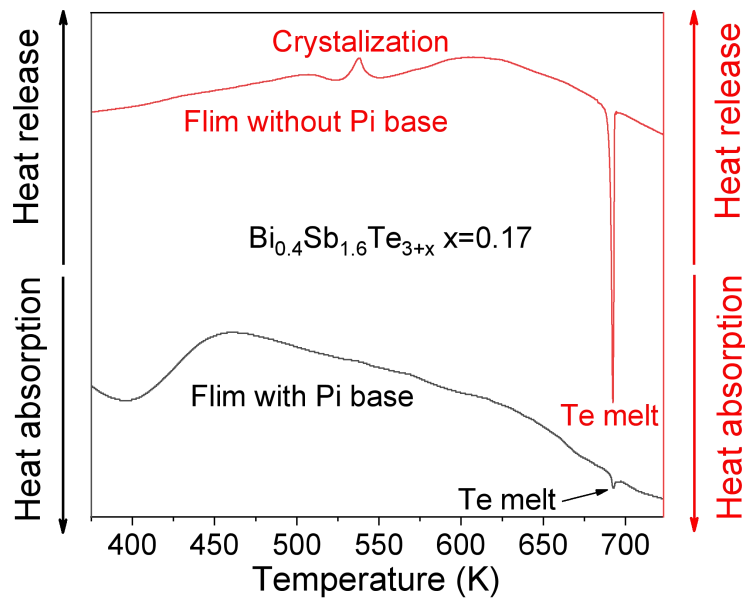


Fig. S4. **Heat flow change due to Te melting.** The temperature dependent normalized heat flow of sample  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0.17$ ) with (solid black line) and without (solid red line) substrate PI, the heat absorption peak at  $\sim 690$  K indicates the appearance of extra Te phase transition in the film.

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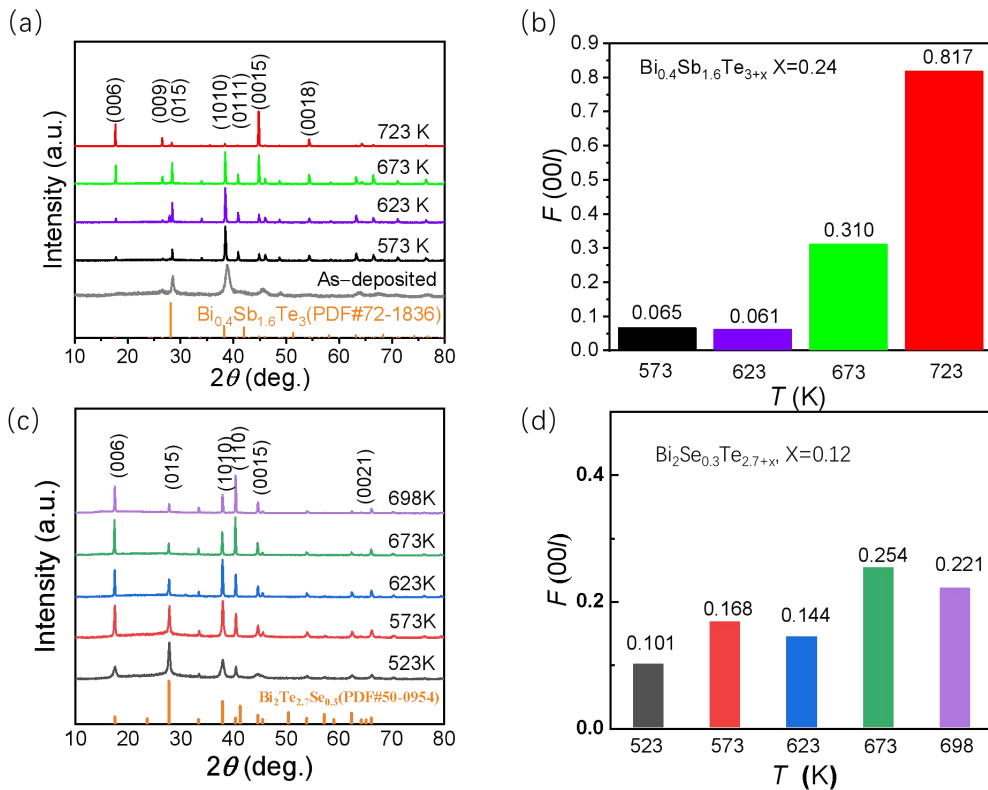
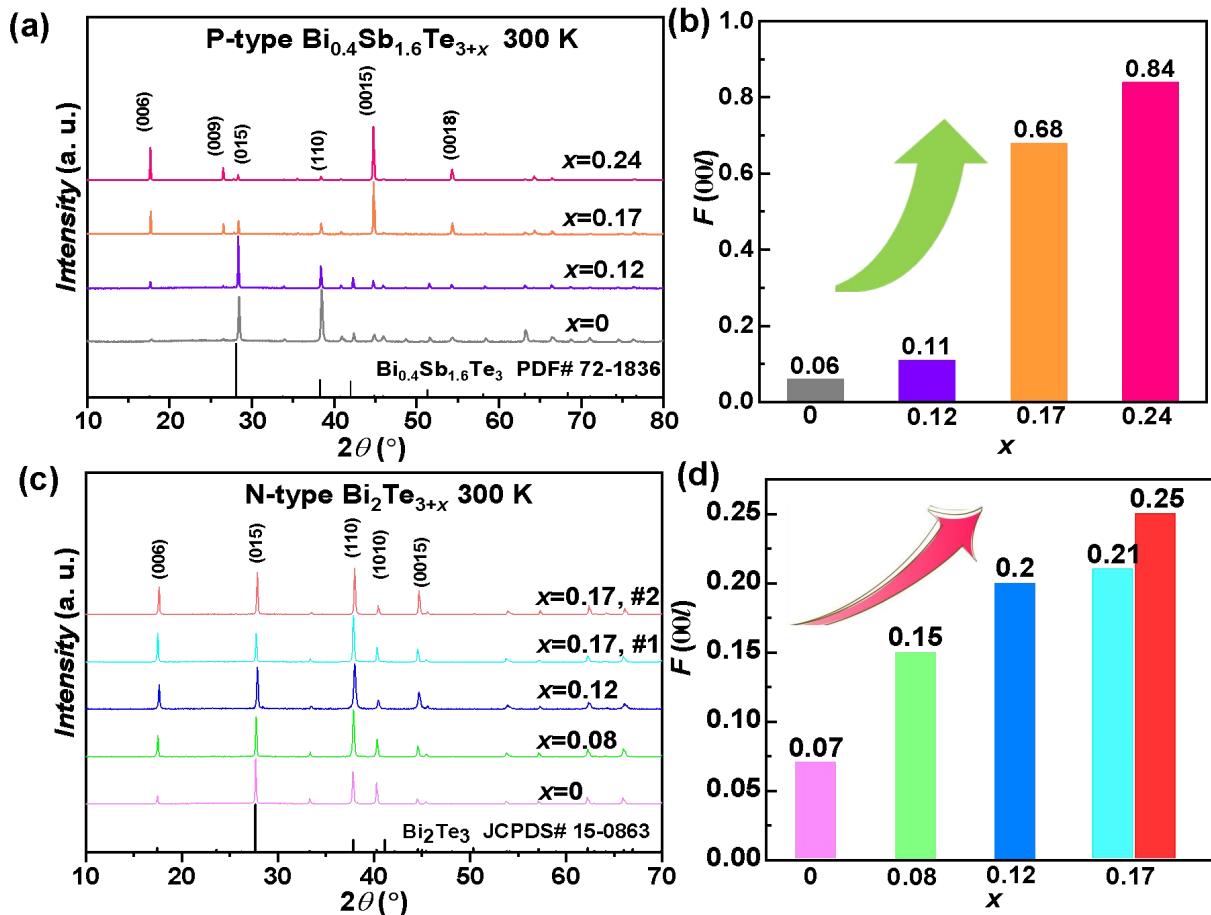


Fig. S5. The orientation enhancement by annealing temperature for Bi<sub>2</sub>Te<sub>3</sub>-based samples. (a, c) The XRD patterns and (b, d) (00l) orientation factor of Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> ( $x=0.24$ ), and Bi<sub>2</sub>Se<sub>0.3</sub>Te<sub>2.7+x</sub> ( $x=0.12$ ) samples annealed at different temperature, respectively.





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Fig. S6. **The orientation enhancement for Bi<sub>2</sub>Te<sub>3</sub>-based samples.** The room temperature XRD patterns and corresponding orientation factor for p-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> films (a, b) and n-type Bi<sub>2</sub>Te<sub>3+x</sub> films (c, d) ( $0 \leq x \leq 0.17$ ); #1 and #2 represent two parallel samples.

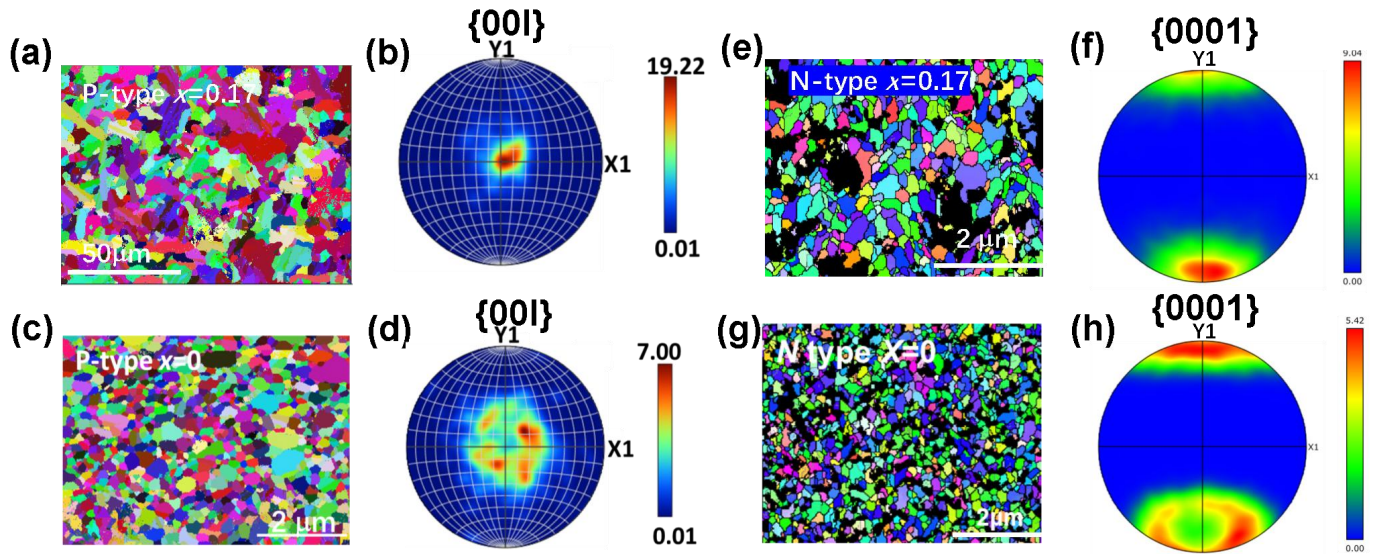


Fig. S7. **EBSD analysis for p-type and n-type samples.** The room temperature EBSD image (a) and inverse pole figure (b) for p-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> ( $x=0.17$ ); EBSD image (c) and inverse pole figure (d) for p-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3</sub>; EBSD image (e) and inverse pole figure (f) n-type Bi<sub>2</sub>Te<sub>3+x</sub> ( $x=0.17$ ); EBSD image (g) and inverse pole figure (h) Bi<sub>2</sub>Te<sub>3</sub> (c~d) films.

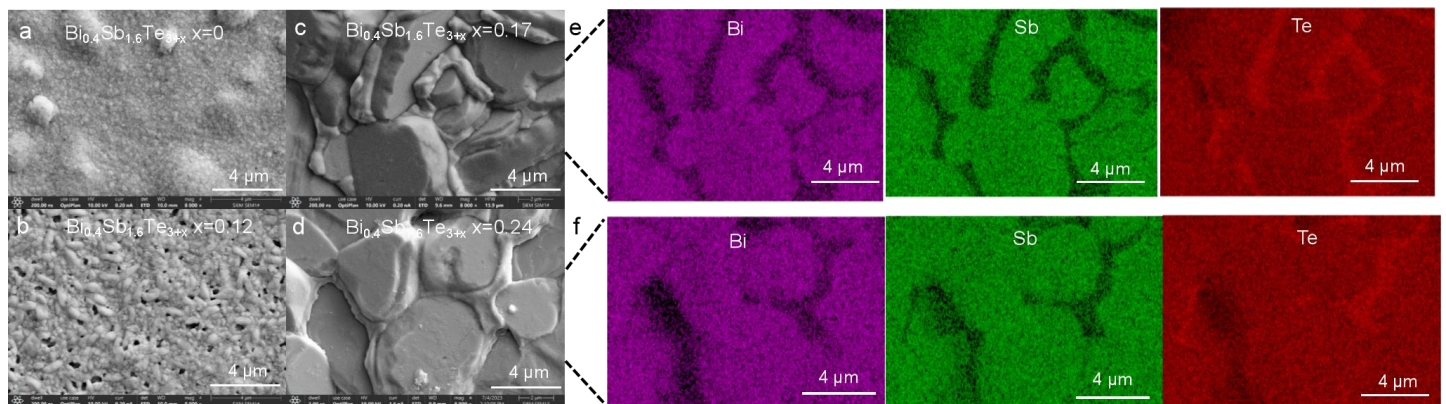


Fig. S8. **The grain size increase for p-type samples.** The room temperature SEM images of p-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub> ( $x=0, 0.12, 0.17, 0.24$ ) samples (a~d), and the EDS analysis for  $x=0.17$  (e~f) and  $x=0.24$  (h~j), indicating the increase of grain size and Te-rich distribution around grain boundary.

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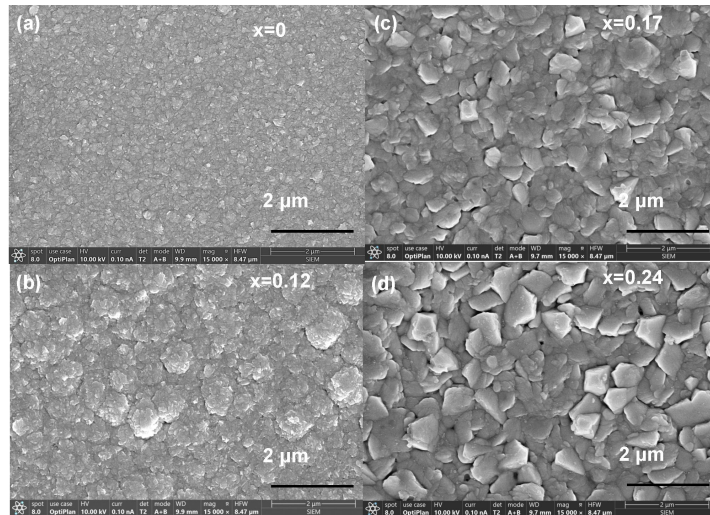


Fig. S9. The room temperature SEM images of n-type  $\text{Bi}_2\text{Te}_{3+x}$  ( $x=0, 0.12, 0.17,$  and  $0.24$ ) (a~d) samples

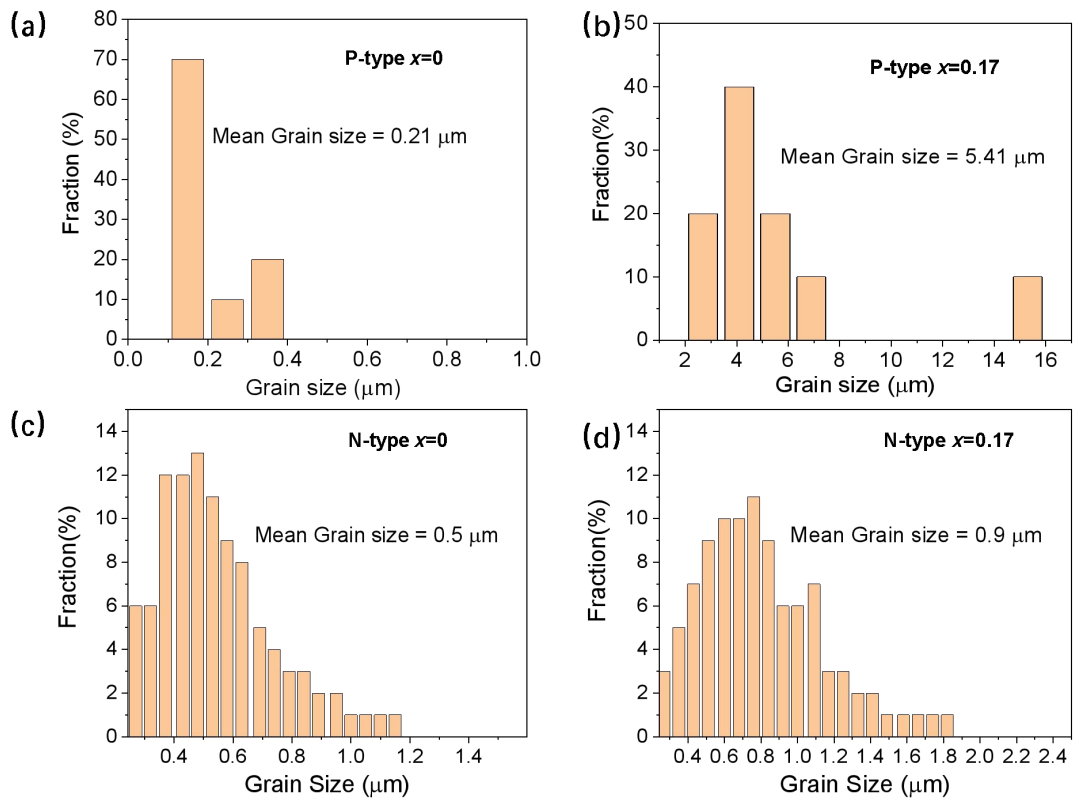


Fig. S10. The grain size distribution for p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  (a~b) and n-type  $\text{Bi}_2\text{Te}_{3+x}$  samples. ( $x=0$  and  $0.17$ ) (c~d) samples



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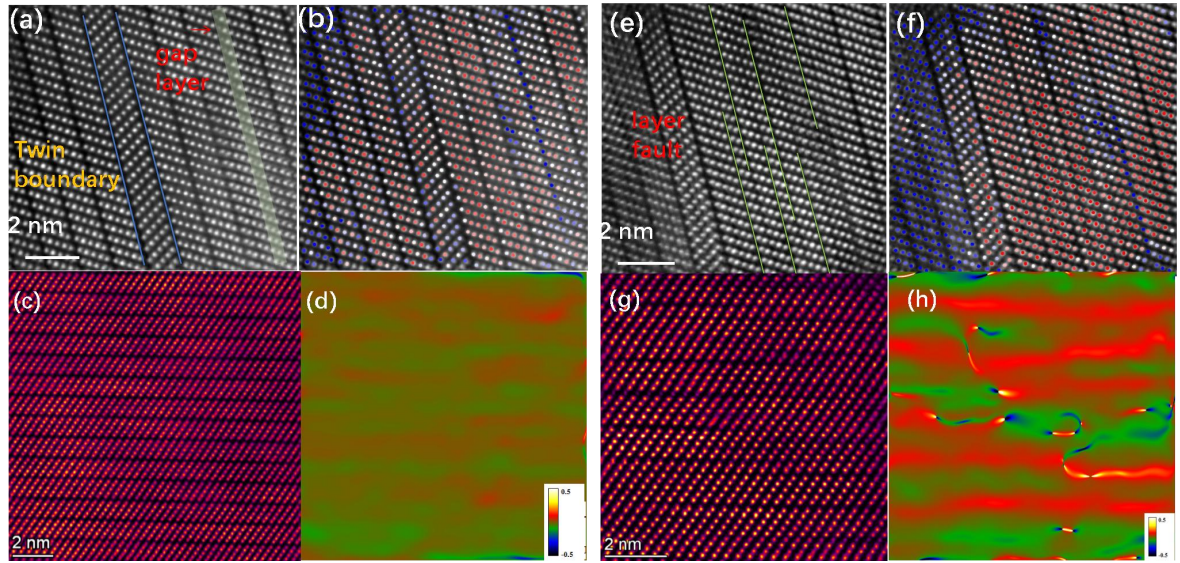


Fig.S11. **HAADF magnified images of regular and staggered layers.** HAADF magnified images (a, b) and corresponding intensity image (e, f) of atom columns utilizing the Z-contrast feature. The blue, green lines point to twin boundary and layer faults, respectively. and GPA analysis image of p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0.17$ ) sample; (c) are for the regular layered structure, (d) is GPA analysis image corresponding (c); (e, f, g) are for staggered stacking fault structure, and (h) is GPA analysis image corresponding (g).

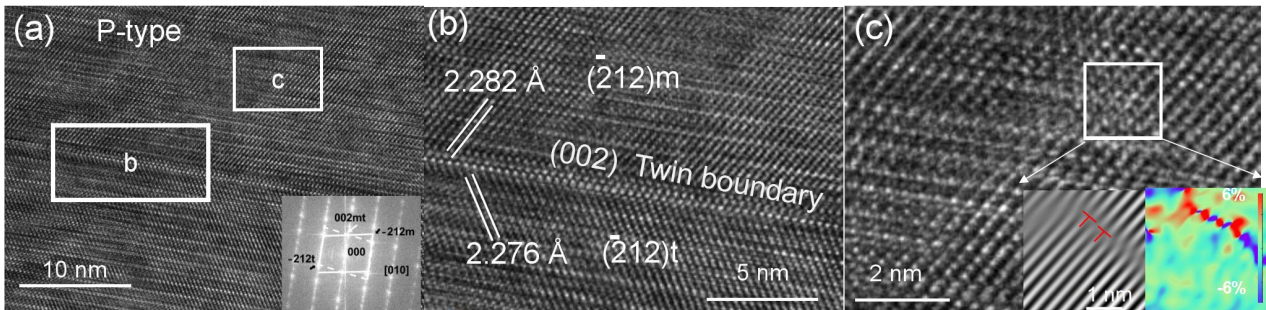


Fig.S12. **TEM image of the staggered layers and dislocation for the p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0.17$ ) sample.**



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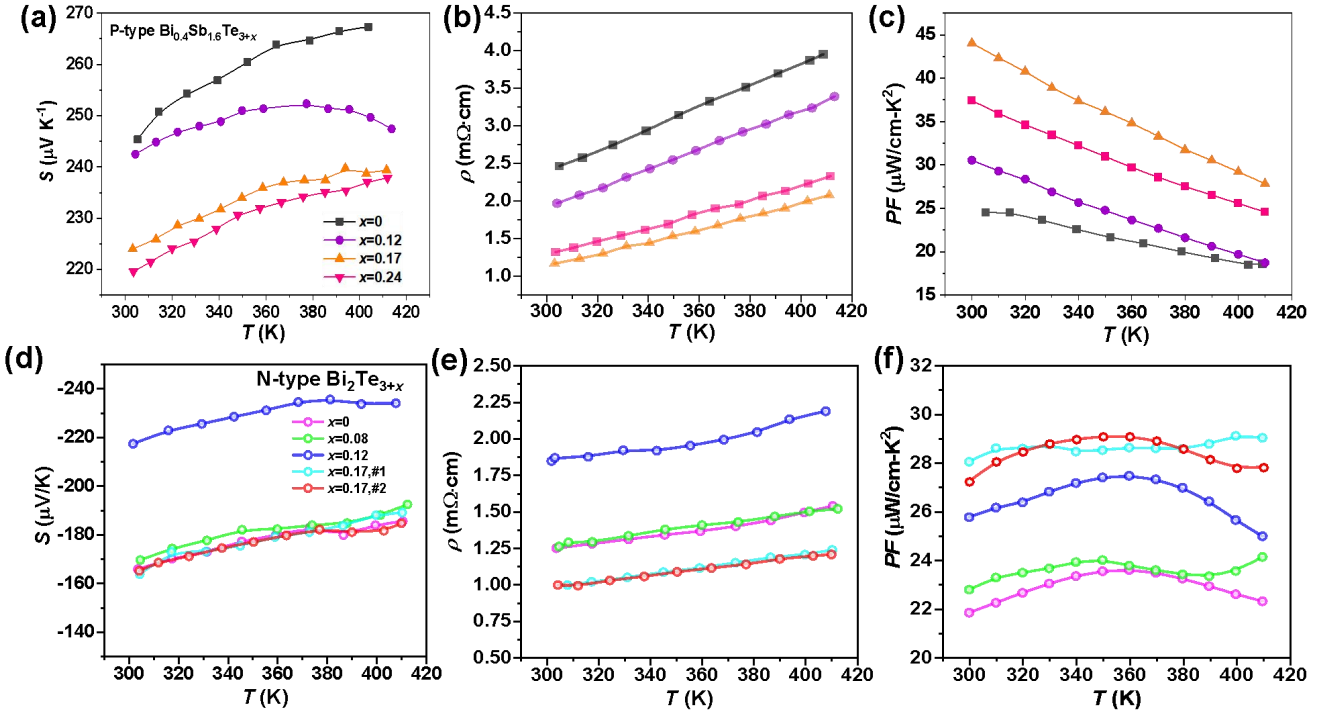


Fig. S13. Electrical properties for n- and p-type  $\text{Bi}_2\text{Te}_3$ -based films. The temperature dependent Seebeck coefficient, resistivity and power factor for p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0, 0.12, 0.17$  and  $0.24$ ) (a~b) and n-type  $\text{Bi}_2\text{Te}_{3+x}$  ( $x=0, 0.08, 0.12$  and  $0.17$ ) (c~d) films in this work. The data of parallel samples #1 and #2 show good consistency in electrical properties

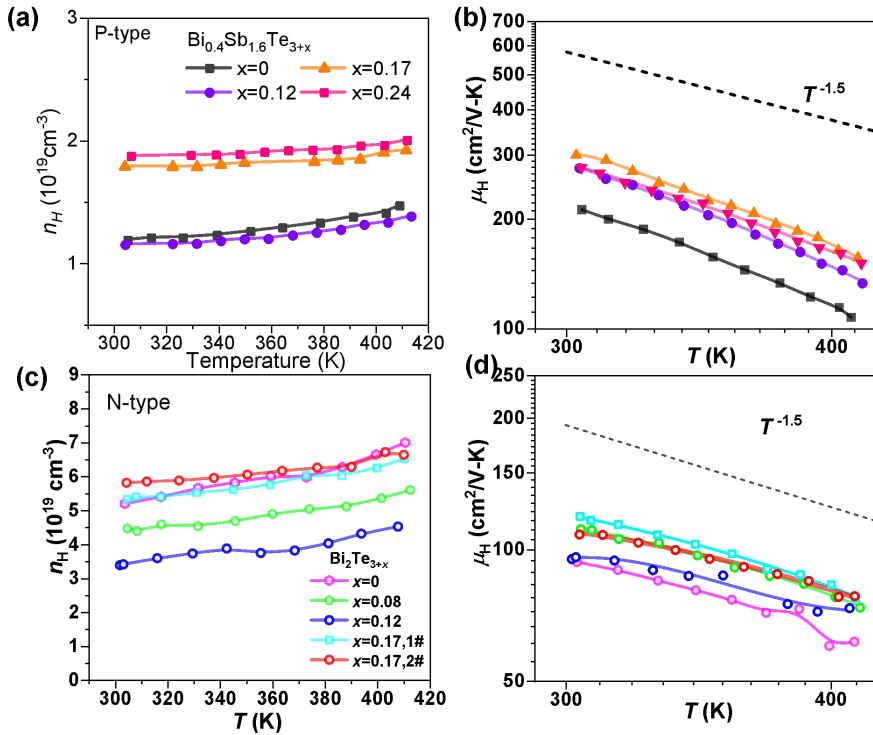


Fig. S14. Electrical properties for p- and n-type  $\text{Bi}_2\text{Te}_3$ -based samples. The temperature dependent hall carrier concentration and hall mobility for p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0, 0.12, 0.17$  and  $0.24$ ) (a~b) and n-type  $\text{Bi}_2\text{Te}_{3+x}$  ( $x=0, 0.08, 0.12$  and  $0.17$ ) (c~d) films in this work. The  $T^{-1.5}$  temperature dependence of hall mobility indicated the dominated acoustic phonon scattering in this work.

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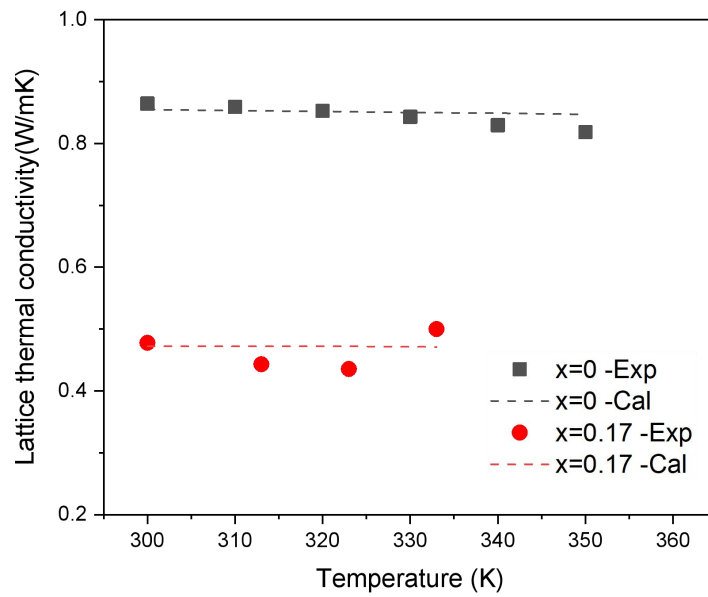


Fig. S15. The calculated Lattice thermal conductivity properties for *p*-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0$  and  $0.17$ ). The experimental data are showed by scatter dots and the lines are the calculated results according to Debye-Callaway model.

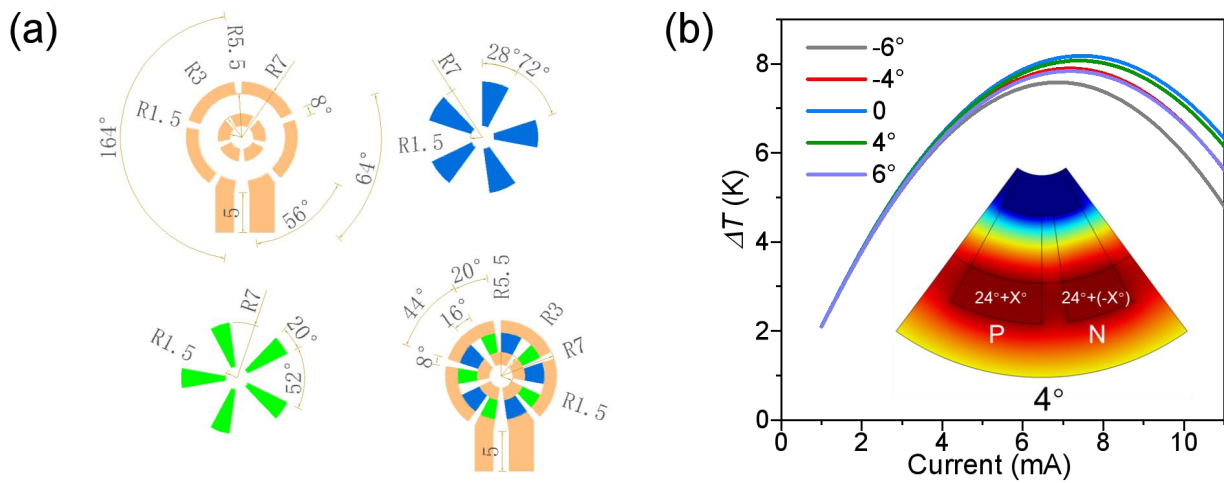


Fig.S16. **Planar device size and simulation process.** The optimized geometry size of the planar device (a), and simulated temperature difference when changing p and n leg angle (b).

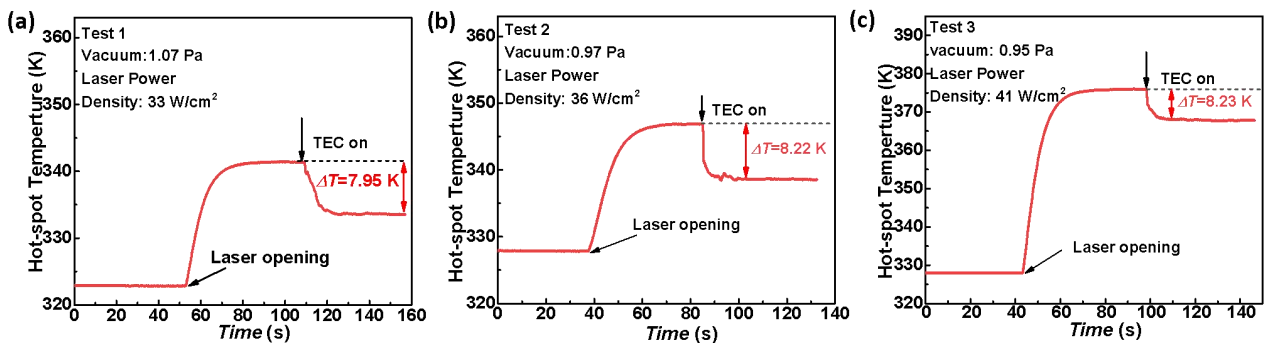


Fig. S17. **Cooling ability of planar f-TEC for laser heating hot spot.** The cooling ability of the f-TEC device prepared in this work measurement with difference laser heating power. Three times test results show  $\sim 8$  K temperature cooling.

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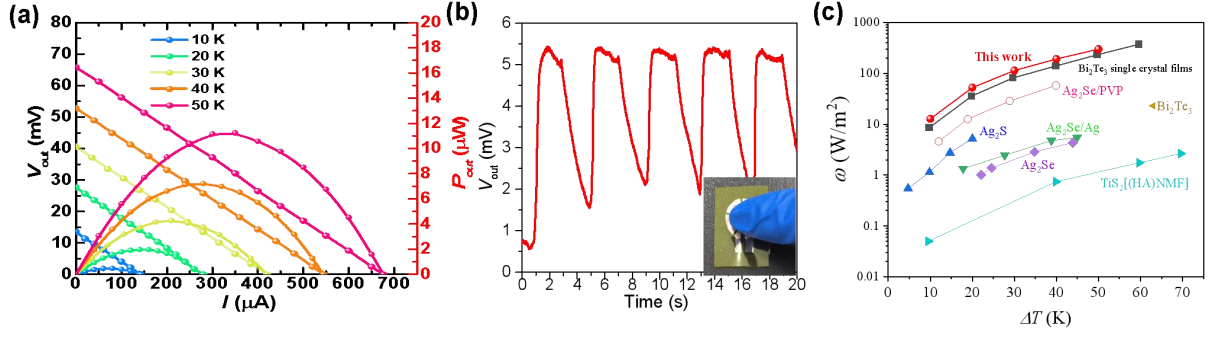


Fig. S18. **Output power of planar film thermoelectric device.** The current dependent voltage and output power at different temperature different (a), and the body heating generated voltage at room temperature (b) of the film thermoelectric device prepared in this work. the output power density of various of film TEGs published (c)<sup>12,17,25-29</sup>.

Table S1. The final compositions of p-type  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  and n-type  $\text{Bi}_2\text{Te}_{3+x}$  films determined by EDS.

Samples	Extra Te content	Bi(at%)	Sb(at%)	Te(at%)
$\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$	$x=0$	8.81	33.92	57.26
	$x=0.12$	8.67	32.18	59.14
	$x=0.17$	8.17	32.2	59.63
	$x=0.24$	8.32	32.19	59.48
$\text{Bi}_2\text{Te}_{3+x}$	$x=0$	40.2	-	59.8
	$x=0.08$	40.3	-	59.7
	$x=0.12$	40.3	-	59.7
	$x=0.17$	40.4	-	59.6

Table. S2. The length  $L$ ,  $\alpha_{\text{mea}}$ ,  $\alpha_{\text{sub}}$ ,  $\alpha_{\text{con}}$ ,  $\alpha_{TE}$ , and the final calculated  $\kappa_{TE}$  in thermal diffusion coefficient determination for sample  $\text{Bi}_2\text{Te}_{3+x}$  ( $x=0$  and  $0.17$ ).

Sample	$T$ (K)	$L$ (mm)	$\alpha_{\text{mea}}$ (mm <sup>2</sup> /s)	$\alpha_{\text{sub}}$ (mm <sup>2</sup> /s)	$\alpha_{\text{con}}$ (mm <sup>2</sup> /s)	$\alpha_{TE}$ (mm <sup>2</sup> /s)	$\alpha_{TE}$ (W/mK)
$x=0$	300	1.638	1.70				
		1.859	2.08	0.33	0.41	0.81	0.98
	330	1.953	2.26				
		1.638	1.71				
		1.859	2.11	0.36	0.43	0.82	0.98
		1.953	2.25				
	350	1.638	1.74				
		1.859	2.15				
		1.953	2.27	0.38	0.46	0.87	1.04
		1.766	1.73				
1.916		1.94					
$x=0.17$	300	1.529	1.43				
		1.702	1.68	0.33	0.45	0.67	0.81
	330	1.785	1.79				
		1.529	1.47	0.36	0.49	0.73	0.88
		1.702	1.71				

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	1.785	1.82				
	1.637	1.74				
350	1.859	2.15	0.38	0.51	0.75	0.90
	1.953	2.27				

Table. S3. The  $L$ ,  $\alpha_{mea}$ ,  $\alpha_{sub}$ ,  $\alpha_{con}$ ,  $\alpha_{TE}$ , and the final calculated  $\kappa_{TE}$  in thermal diffusion coefficient determination for sample  $\text{Bi}_{0.4}\text{Sb}_{1.6}\text{Te}_{3+x}$  ( $x=0, 0.12, 0.17$  and  $0.24$ ).

Sample	$T$ (K)	$L$ (mm)	$\alpha_{mea}$ (mm <sup>2</sup> /s)	$\alpha_{sub}$ (mm <sup>2</sup> /s)	$\alpha_{con}$ (mm <sup>2</sup> /s)	$\alpha_{TE}$ (mm <sup>2</sup> /s)	$\kappa_{TE}$ (W/mK)	
$x=0$	300	0.938	0.60					
		1.283	0.60	0.32	0.49	0.77	1.06	
		2.313	0.99					
	325	0.938	0.58					
		1.283	0.76	0.35	0.50	0.75	1.04	
		2.313	1.19					
	350	0.938	0.60					
		1.283	0.75	0.37	0.50	0.72	0.99	
		2.313	1.22					
	$x=0.12$	300	0.938	0.60				
			0.454	0.46				
			1.018	1.20	0.32	0.48	0.74	1.02
300		1.814	2.31					
		2.559	4.09					
		0.494	0.51					
300		0.812	0.65	0.32	0.46	0.68	0.89	
		1.575	1.06					
		2.592	2.16					
313		0.494	0.50					
		0.812	0.64	0.35	0.46	0.65	0.85	
		1.575	1.10					
323	2.592	2.15						
	0.494	0.52						
	0.812	0.63	0.35	0.46	0.63	0.83		
$x=0.17$	323	1.575	1.13					
		2.592	2.23					
		0.494	0.55					
333	0.812	0.64	0.36	0.49	0.69	0.91		
	1.575	1.22						
	2.592	2.32						
343	0.494	0.58						
	0.812	0.66	0.37	0.50	0.71	0.93		
	1.575	1.21						
353	2.592	2.40						
	0.494	0.62						
	0.812	0.67	0.38	0.52	0.76	0.99		
$x=0.24$	300	1.575	1.33					
		2.592	2.56					
		1.575	0.72	0.32	0.51	0.80	1.06	
		2.592	0.93					



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	0.494	1.42				
	0.812	0.78				
325	1.575	0.96	0.35	0.51	0.76	1.02
	2.592	1.57				
	0.738	0.76				
350	1.126	1.40	0.38	0.58	0.92	1.24
	1.591	2.24				

**Table S4.** The Fitting Results according to Debye-Callaway Model for *p*-type Bi<sub>0.4</sub>Sb<sub>1.6</sub>Te<sub>3+x</sub>(*x*=0 and 0.17).

Samples	<i>L</i> ( $\mu\text{m}$ )	<i>A</i> ( $10^{-41} \text{ s}^3$ )	<i>B</i> ( $10^{-18} \text{ sK}^{-1}$ )	<i>C</i> ( $10^{-31} \text{ s}^2$ )	<i>D</i> ( $10^{-3}$ )	<i>E</i> ( $10^{-15} \text{ s}$ )
Bi <sub>0.4</sub> Sb <sub>1.6</sub> Te <sub>3</sub>	0.21	2.74	1.70	1.03	1.81	4.50
Bi <sub>0.4</sub> Sb <sub>1.6</sub> Te <sub>3+0.17</sub>	5.41	3.91	1.70	4.48	7.88	8.99

**Table S5.** Parameters Used for the Debye-Callaway Model

Parameters	Description	Values
$\theta_D$	Debye temperature	164 K <sup>17</sup>
$v_l$	Longitudinal sound velocity	2800 m/s <sup>17</sup>
$v_t$	Transverse sound velocity	1660 m/s <sup>17</sup>
$v_s$	Average sound speed	1778 m/s <sup>17</sup>
$r$	Poisson's ratio	0.24 <sup>18</sup>
$L$	Average grain size	5.41 $\mu\text{m}$ for <i>x</i> =0.17 sample 0.21 $\mu\text{m}$ for <i>x</i> =0 sample
$\bar{v}$	Average atomic volume	$3.48 \times 10^{-29} \text{ m}^3$
$\bar{M}$	Average atomic mass	$2.66 \times 10^{-25} \text{ kg}$
$\gamma$	Gruneisen parameter	1.5 <sup>19</sup>
$\Gamma$	Point defect scattering parameter	0.053
$B$	Van der waals gap	2.52 $\text{\AA}$
$N_d$	Dislocation density	$5.56 \times 10^{16} \text{ m}^{-2}$ for <i>x</i> =0.17 sample (fitted) $1.28 \times 10^{16} \text{ m}^{-2}$ for <i>x</i> =0 sample (fitted)
$N_s$	Number of staggered layers in a line of unit length	$1.66 \times 10^8 \text{ m}^{-1}$ for <i>x</i> =0.17 sample (fitted) $0.80 \times 10^8 \text{ m}^{-1}$ for <i>x</i> =0 sample (fitted)

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